

F-7859

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Junichi ISHIZUKA
Filed : July 14, 2003
For : MOLDING METHOD OF MICROLENS ARRAY
AND MOLDING APPARATUS OF THE SAME

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Commissioner for Patents
P.O. Box 1450
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INFORMATION DISCLOSURE STATEMENT

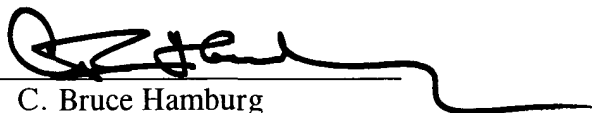
Sir:

Submitted herewith is an Information Disclosure Citation together with
copies of references referred to therein.

Respectfully submitted,

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By



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							Yes No
		2001-48554	2/20/01	JP			
		2000-1322	1/7/03	JP			
TRANSLATION KEY: * English Abstract. ^F Concise statement of relevance provided in foreign search report. ^C Concise statement of relevance provided in specification. ^S Concise statement of relevance provided in IDS. ^P Relevant portion of reference translated. ^O English abstract only - copy of reference in pct search.							
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